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Rhonda N. Hunt

- 1 -

Docket: 0756-958

305-102

6p 2508

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re PATENT application of

Shunpei YAMAZAKI et al.

Serial No. 08/183,800

Filed: January 21, 1994

For: SEMICONDUCTOR MATERIAL
AND METHOD FOR FORMING
THE SAME AND THIN FILM
TRANSISTOR

)
)
) Art Unit: 2508
) Examiner: M. Saadat
)
)
)
) Date: February 3, 1995

#21/E
[Signature]
3/7/95

AMENDMENT

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

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In response to the Office Action of September 7, 1994, please amend the subject application as follows:

IN THE CLAIMS:

Cancel claims ~~5-14~~ without prejudice.

Add new claims 32-35.

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